

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Yee-Chung Fu
Assignee: Advanced NuMicro Systems, Inc.
Amended Title: MEMS Scanning Mirror with Trenched Surface and Tapered Comb Teeth for Reducing Inertia and Deformation
Serial No.: 10/779,952 Filing Date: February 13, 2004
Examiner: Allan R. Wilson Group Art Unit: 2815
Docket No.: ANS-P105

San Jose, California
May 23, 2006

Mail Stop Amendment
Under Secretary of Commerce for Intellectual Property and Director of the
United States Patent and Trademark Office
P.O. Box 1450
Alexandria, Virginia 22313-1450

AMENDMENT

Dear Sir:

In response to the February 23, 2006 Office Action, please amend the above-identified application as follows:

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 7 of this paper.